

Ultra-compact polarimeters on a silicon chip

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Outline

- Introduction
 - Performance in presence of noise
- Full-Stokes polarimeters in silicon photonics
- Spectropolarimeter on a silicon chip





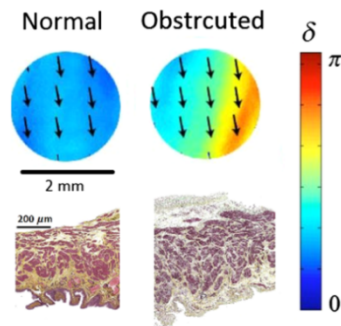
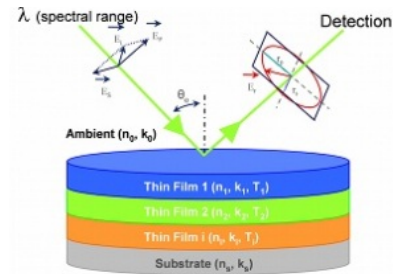
Parallel processing of
polarization & intensity

Fiddler Crab

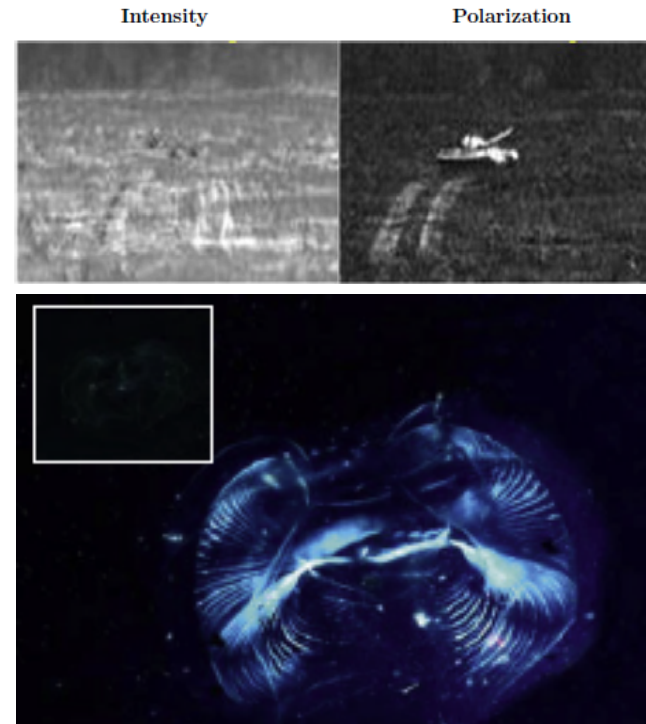
Samuel P. Smithers et al., SCIENCE ADVANCES, 2019.

Polarization conveys some unique information

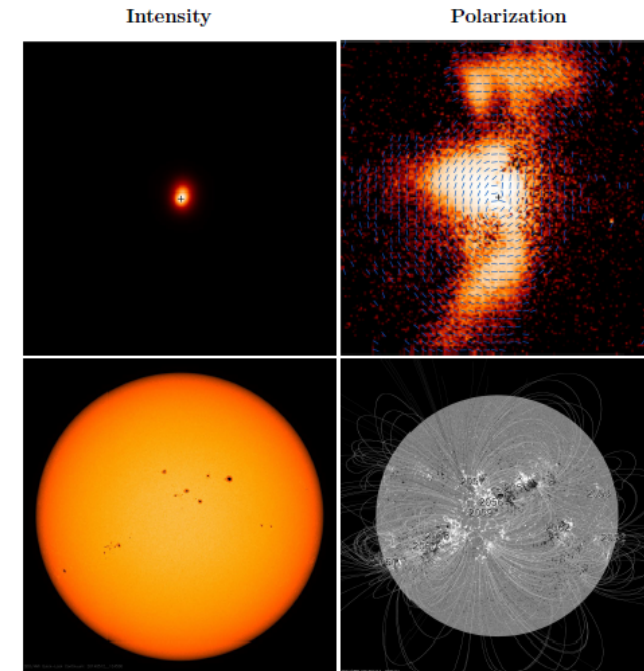
Material: optical constant



Target detection: identify the object from the background



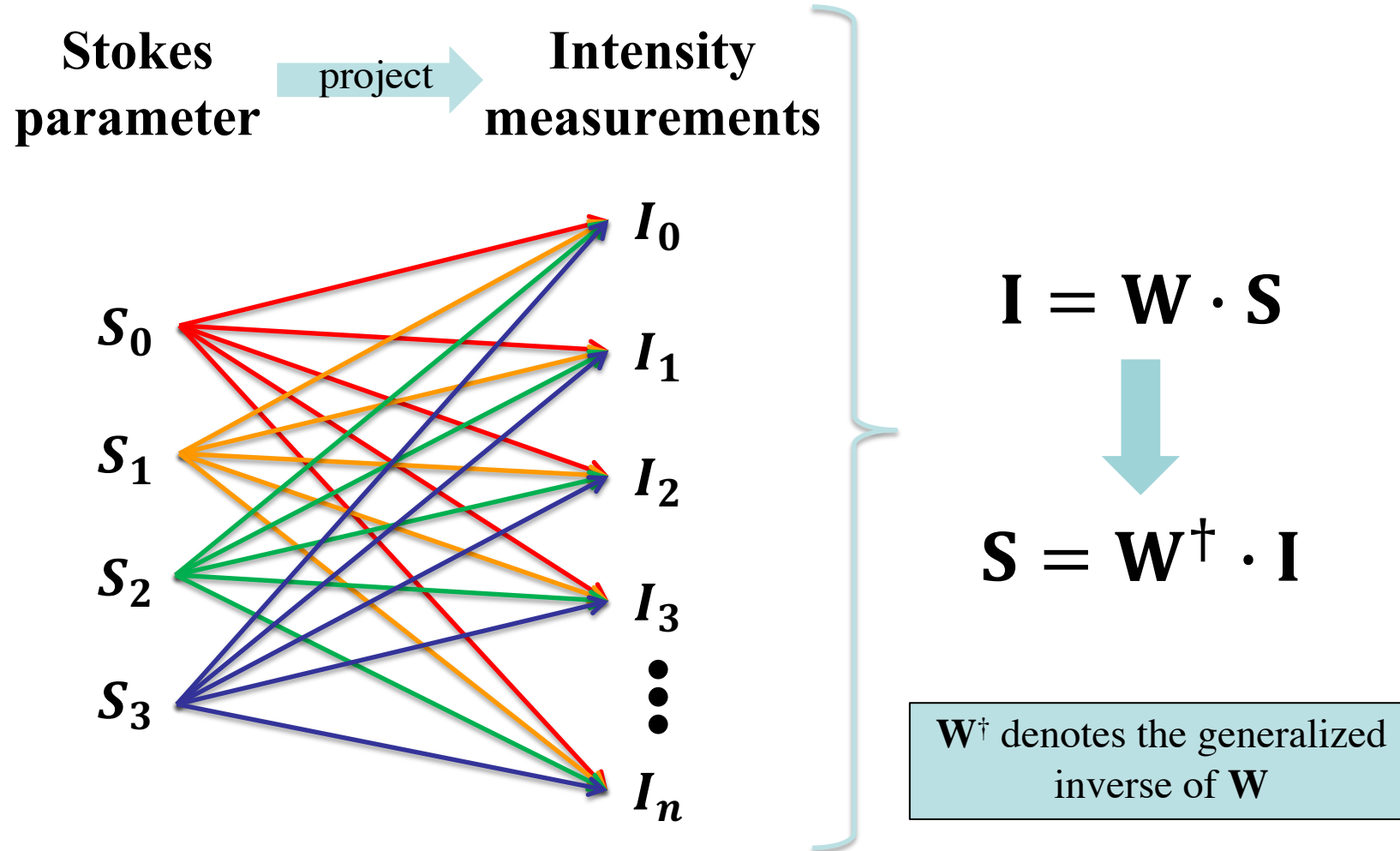
Astronomy: magnetic field distribution



[1] Wehner, R. *J Exp Biol* 2001, 204, (Pt 14), 2589-96.

[2] Wang, X.; Yan, X.; Lv, G.; Fan, T. *Infrared Physics & Technology* 2013, 58, 5-11.

Stokes polarimetry: measurement principle



Stokes polarimetry: influence of noise

rank ($\mathbf{W}^\dagger$) = 4, full-Stokes vector can be reconstructed

$$\mathbf{S} = \mathbf{W}^\dagger \cdot \mathbf{I}$$

$$\mathbf{S}' = \mathbf{W}^\dagger \cdot (\mathbf{I} + \Delta \mathbf{I}) \quad \Rightarrow \quad \Delta \mathbf{S} = \mathbf{W}^\dagger \cdot \Delta \mathbf{I}$$

$\Delta \mathbf{I}$ is Gaussian noise: $\frac{\|\Delta \mathbf{S}\|}{\|\mathbf{S}\|} \leq \frac{\|\mathbf{W}^\dagger\| \cdot \|\Delta \mathbf{I}\|}{\|\mathbf{W}\| \cdot \|\mathbf{I}\|}$ Condition number:
Minimum value $\sqrt{3}$

$\Delta \mathbf{I}$ is Poisson noise:
 $(\Delta \mathbf{I})^2 \propto \mathbf{I}$

$$E(\Delta \mathbf{S} (\Delta \mathbf{S})^T) = \mathbf{W}^\dagger \cdot \begin{pmatrix} (\mathbf{WS})_1 & 0 & 0 & \cdots & 0 \\ 0 & (\mathbf{WS})_2 & 0 & \cdots & 0 \\ 0 & 0 & (\mathbf{WS})_3 & \cdots & 0 \\ \vdots & \vdots & \vdots & \ddots & \vdots \\ 0 & 0 & 0 & \cdots & (\mathbf{WS})_n \end{pmatrix} \cdot (\mathbf{W}^\dagger)^T$$

Polarization dependence



Stokes polarimetry: optimal frame

Gaussian noise



κ : condition number

Poisson noise:



$$\Delta\gamma = E(\Delta\mathbf{S}(\Delta\mathbf{S})^T)_{max} - E(\Delta\mathbf{S}(\Delta\mathbf{S})^T)_{min}$$

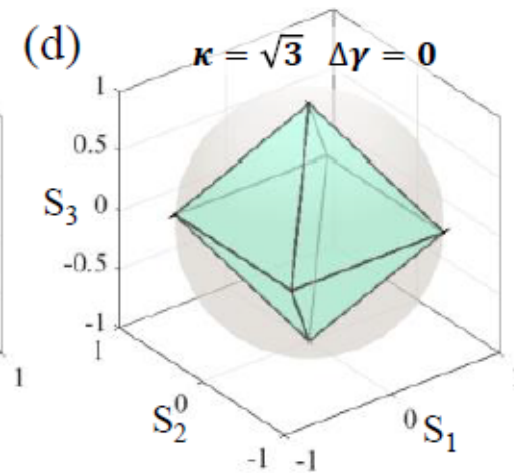
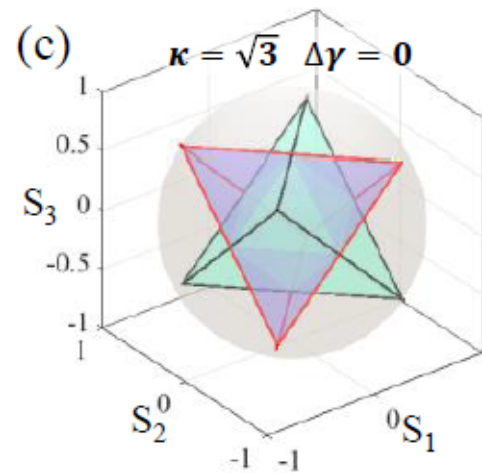
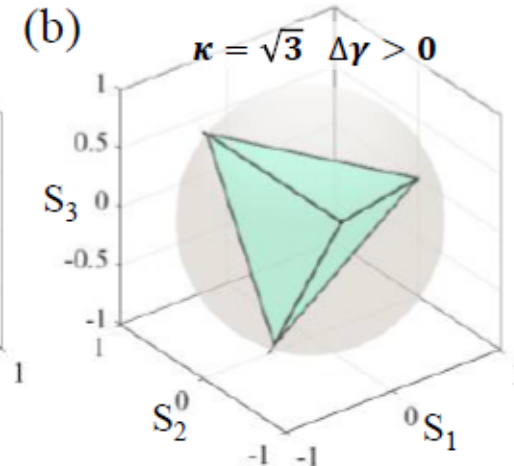
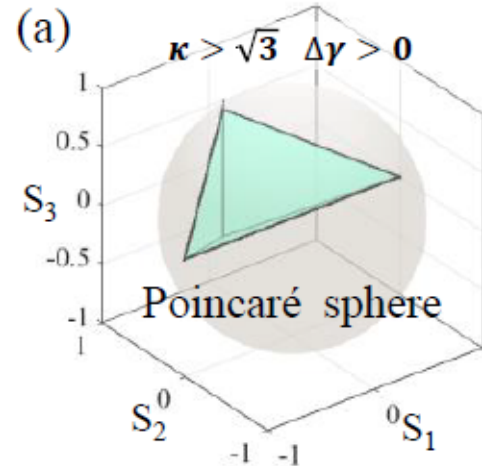
$$W_{i1}^2 = W_{i2}^2 + W_{i3}^2 + W_{i4}^2 = 1$$

Measurement frame:

$$\mathbf{w}_i = (W_{i2}, W_{i3}, W_{i4})$$



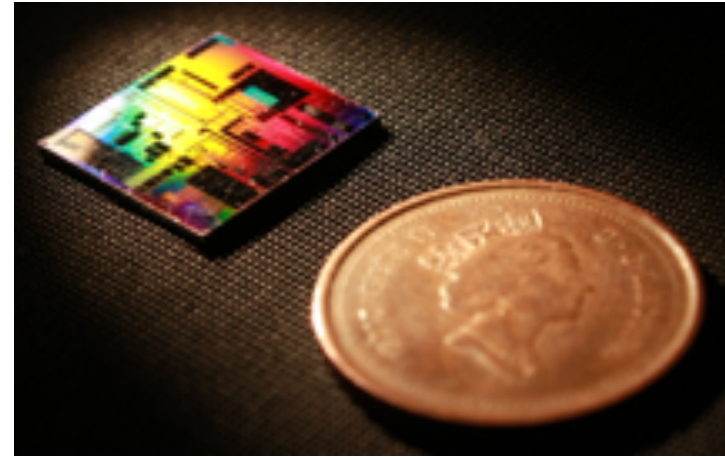
A polyhedron can be built



Polarimeters in silicon photonics: why?

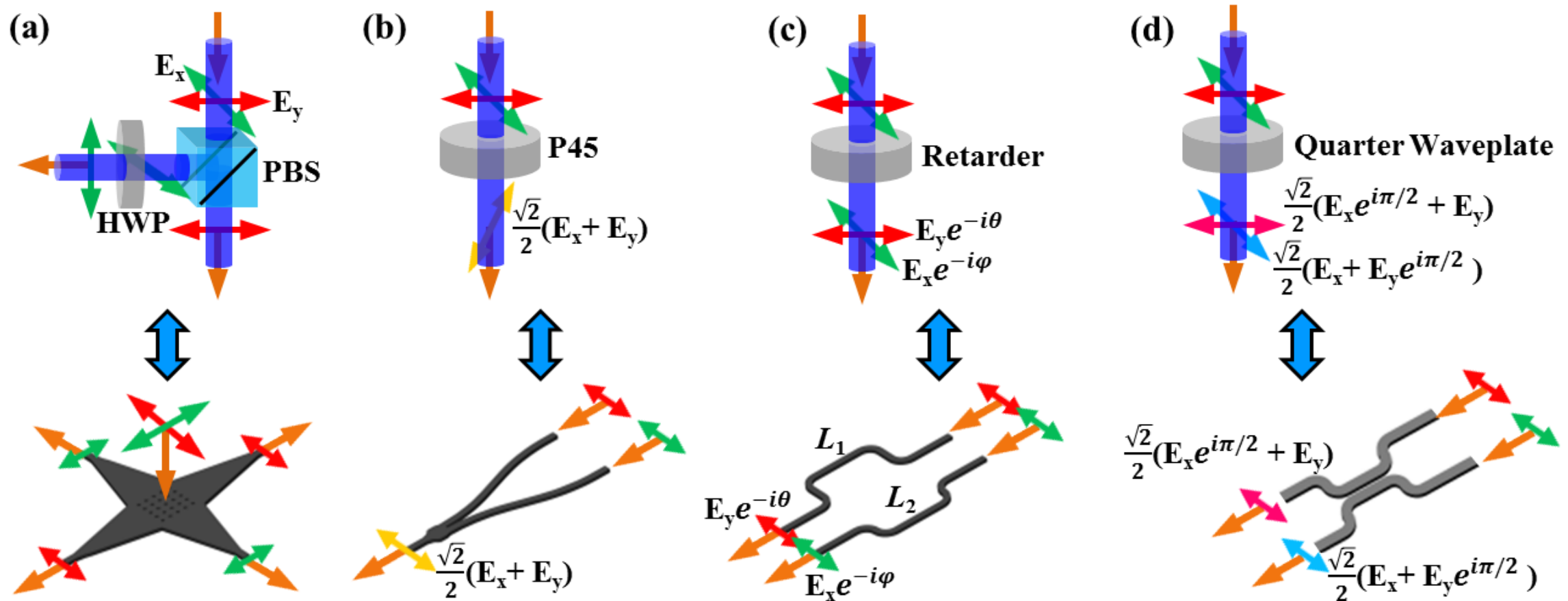


- Large
- Expensive
- Non-portable

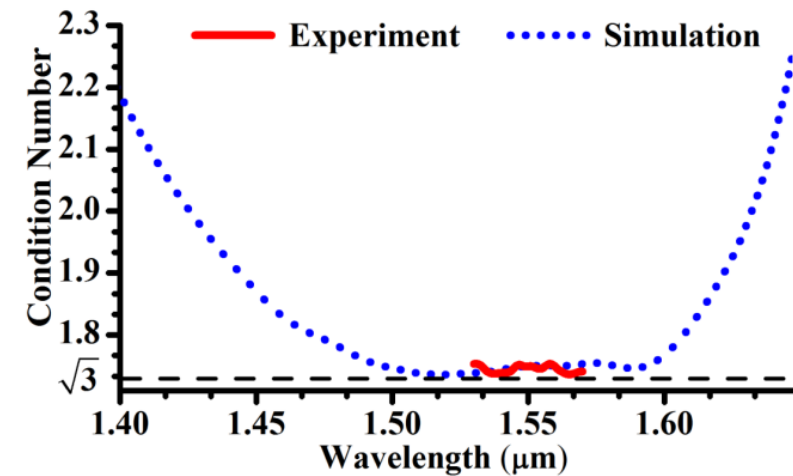
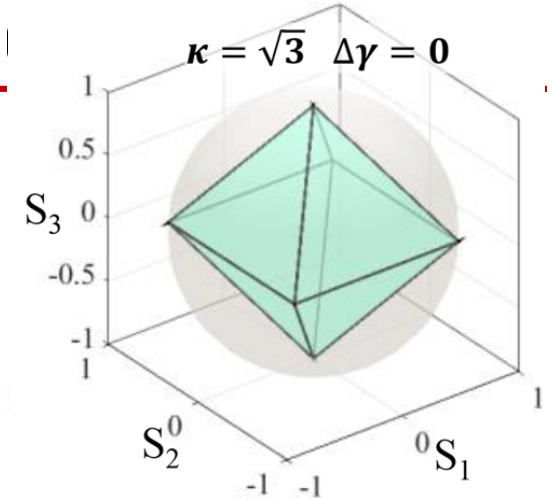
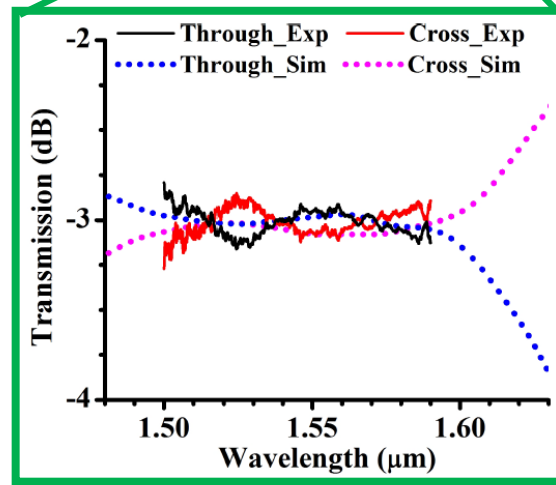
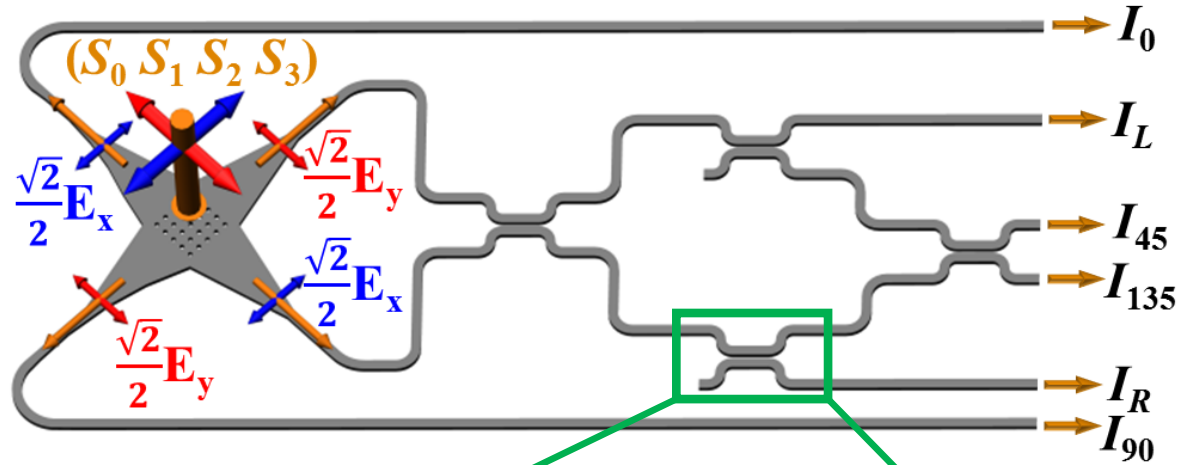


- Compact
- Low-cost
- Portable
- COMS-compatible
- Low power consumption

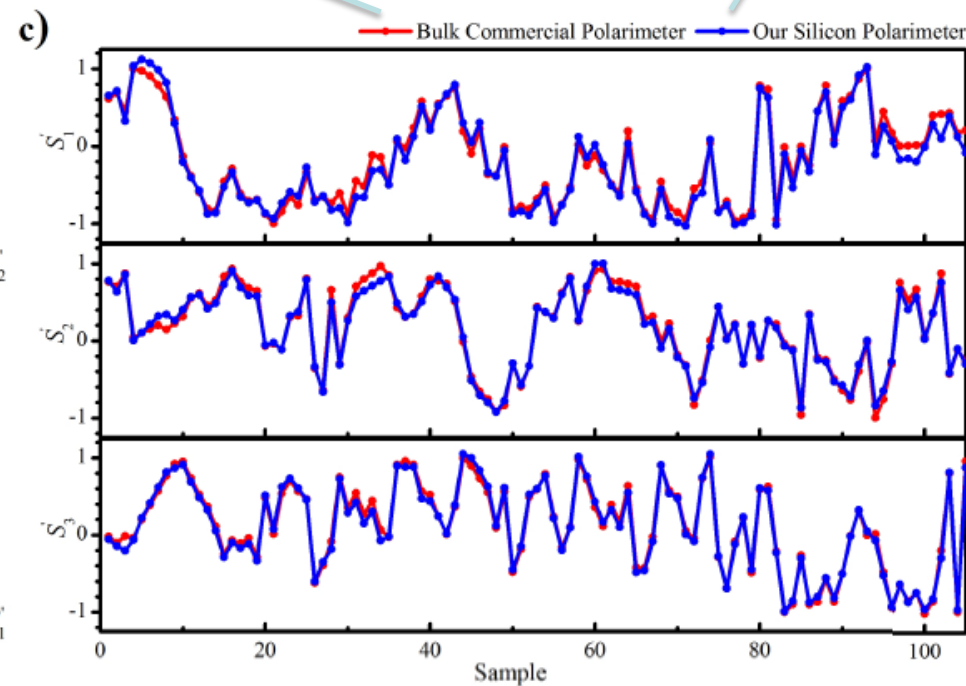
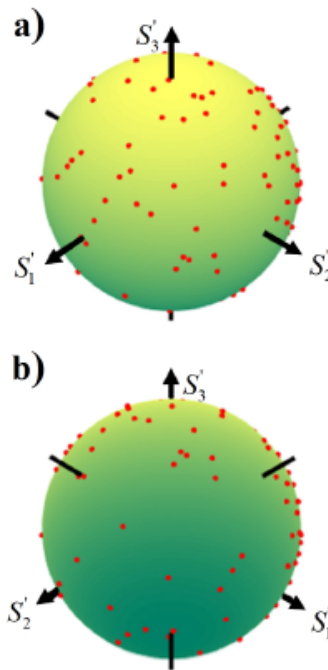
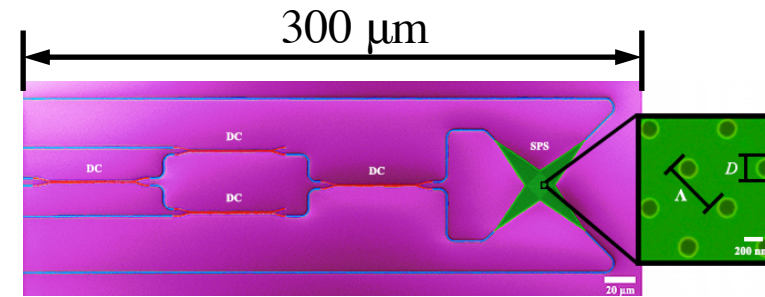
Polarimeters in silicon photonics: how?



Polarimeter with 6 photodetectors



Polarimeter with 6 PDs: experiment



Polarimeters with 4 PDs

The advantage of 6 intensity measurements to 4 intensity measurements:



Less photodetectors



Equally Weighted Variance (EWV):

Poisson noise: $EWV_{Poi} = 10S_0$

Gaussian noise: $EWV_{add} = 10N\sigma_n^2$

Number of intensity measurements

Division of amplitude

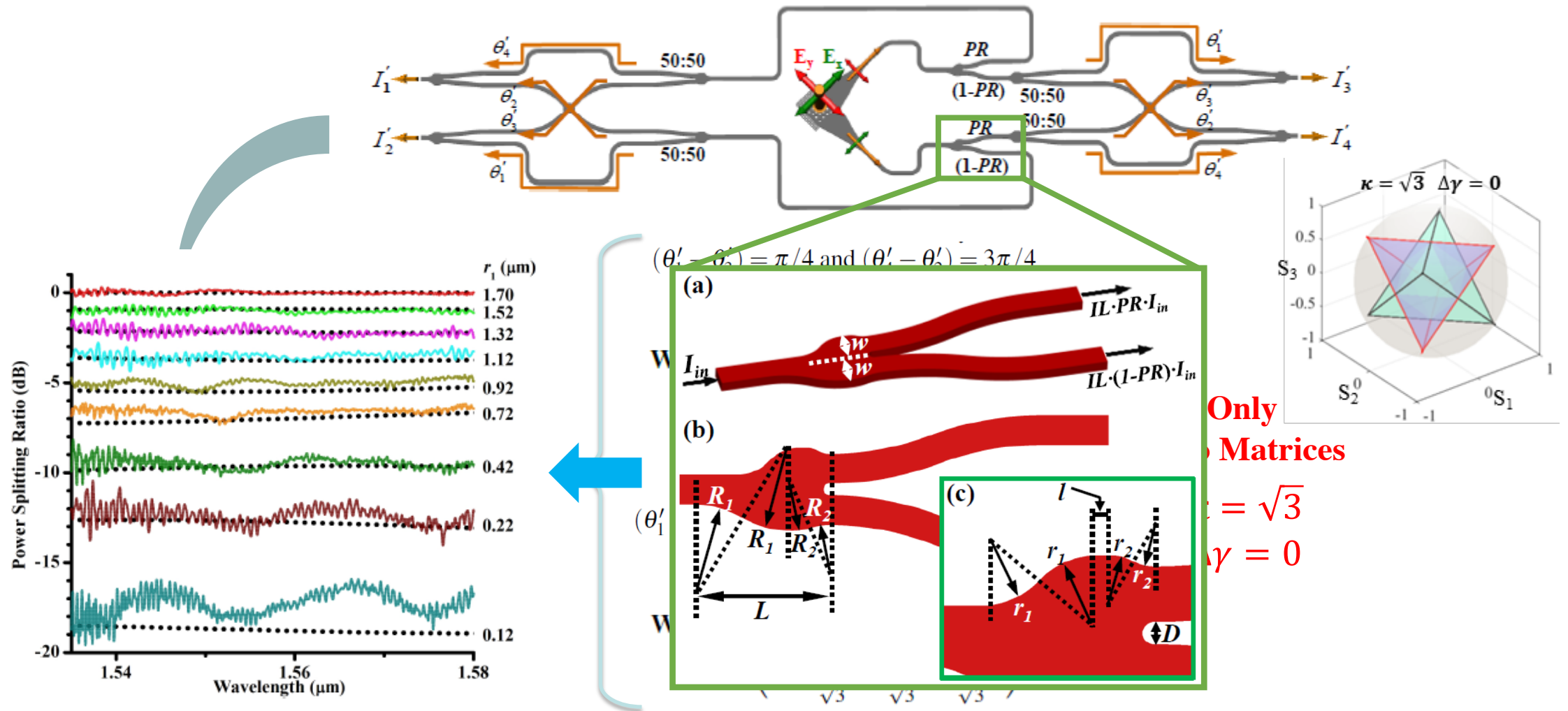
4 PDs

$$\Delta\gamma = 0, \kappa = \sqrt{3}$$

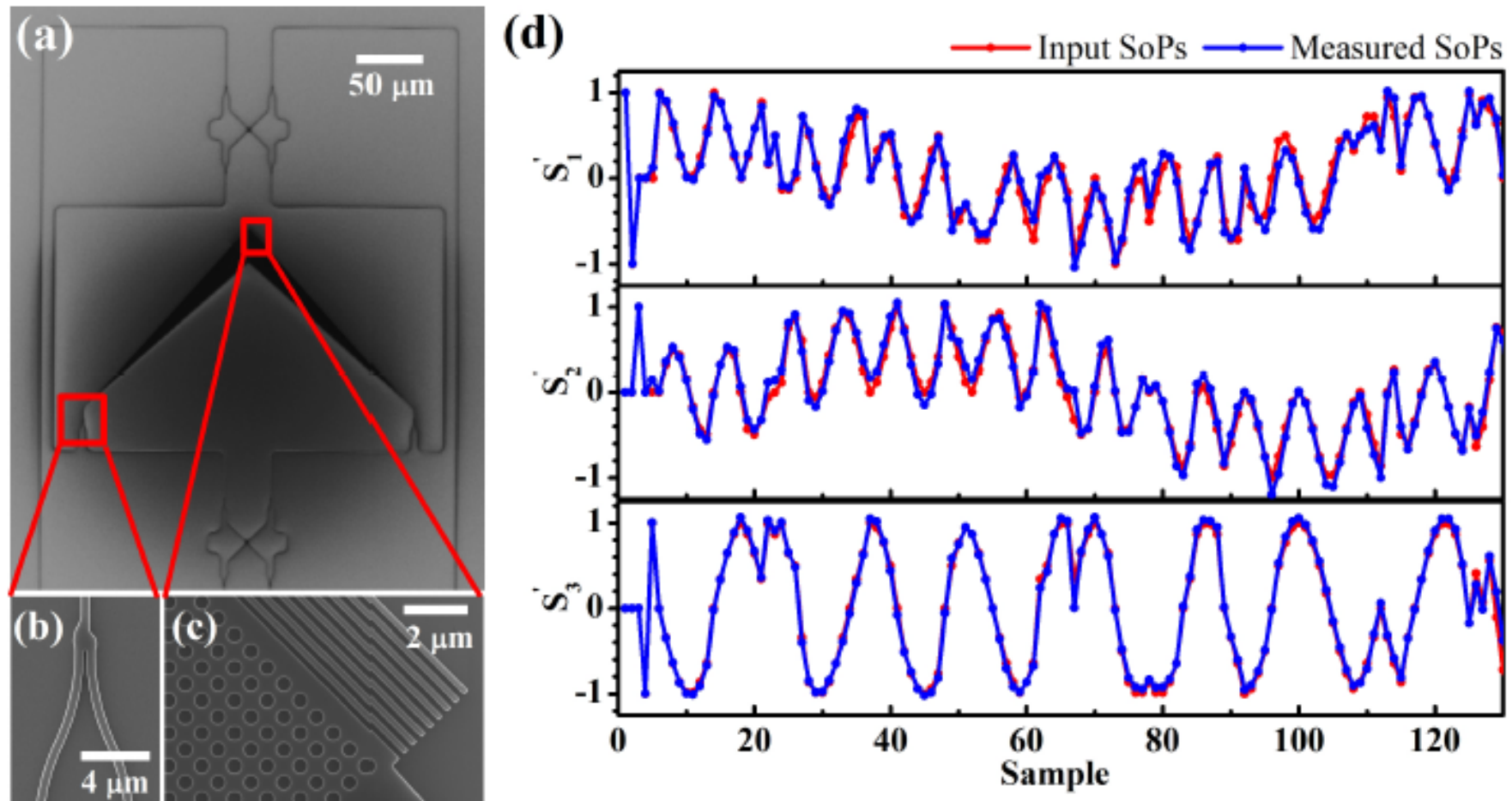


Optimal performance

Polarimeters with 4 PDs: design



Polarimeters with 4 PDs: experiment

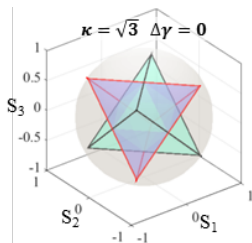
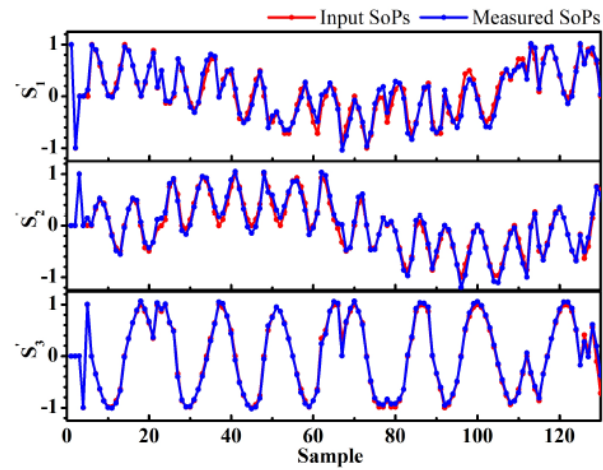
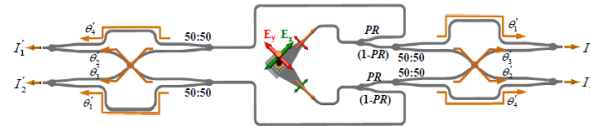


[1] Wei Shi, et al. APL Photonics 4.10 (2019): 100806.

[2] Z. Lin and W. Shi, "Broadband, low-loss silicon photonic Y-junction with an arbitrary power splitting ratio," *Optics Express* 27, 14338–14343 (2019).

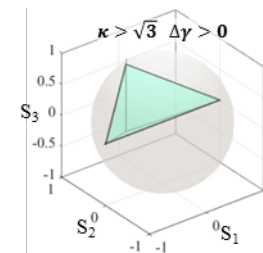
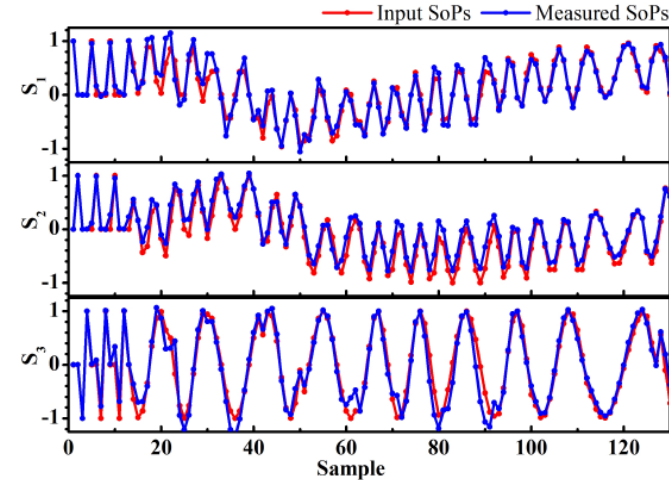
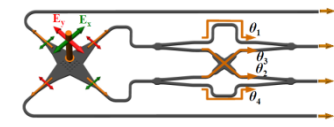
Polarimeters with 4 photodetectors

Optimal



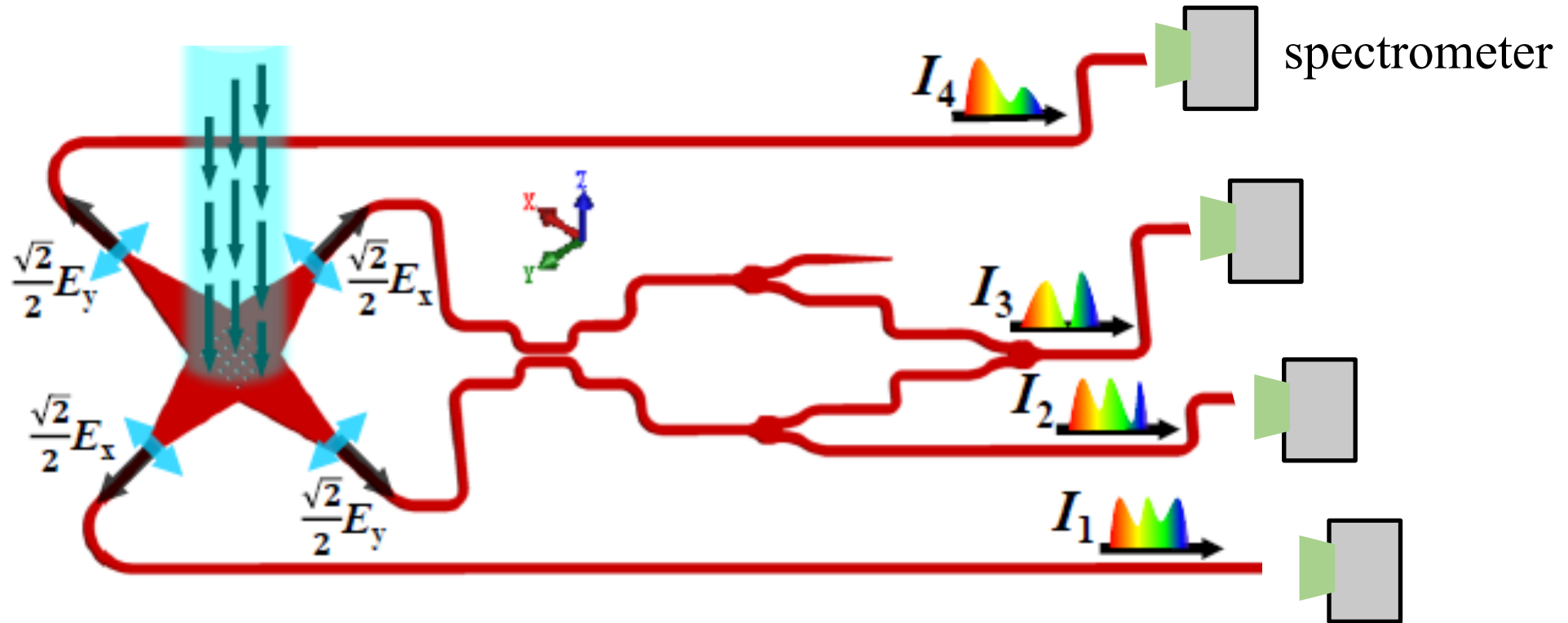
Root-mean-square=0.081

General



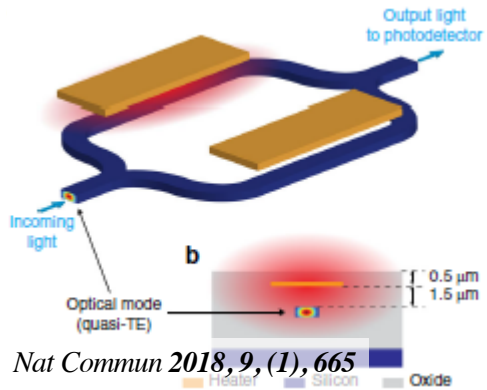
Root-mean-square=0.147

Spectropolarimeter



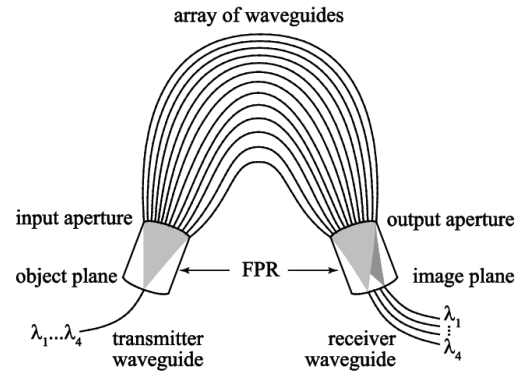
Integrated spectrometers

Fourier transform spectrometers



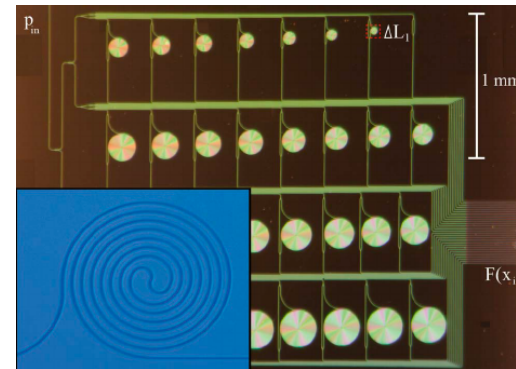
2W tuning

AWG spectrometers



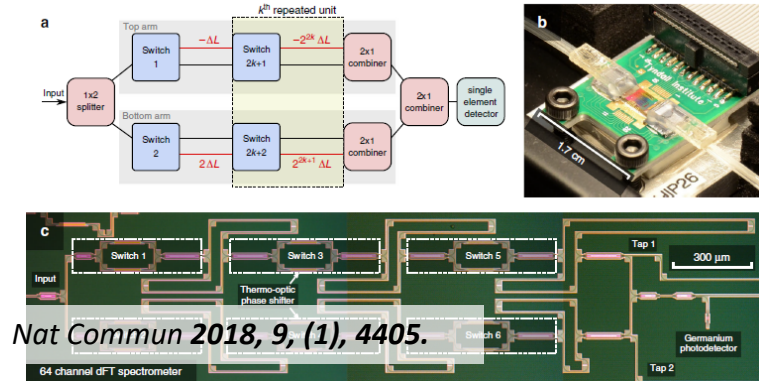
Many PDs
Resolution-BW trade-off

Spatial heterodyne FTS



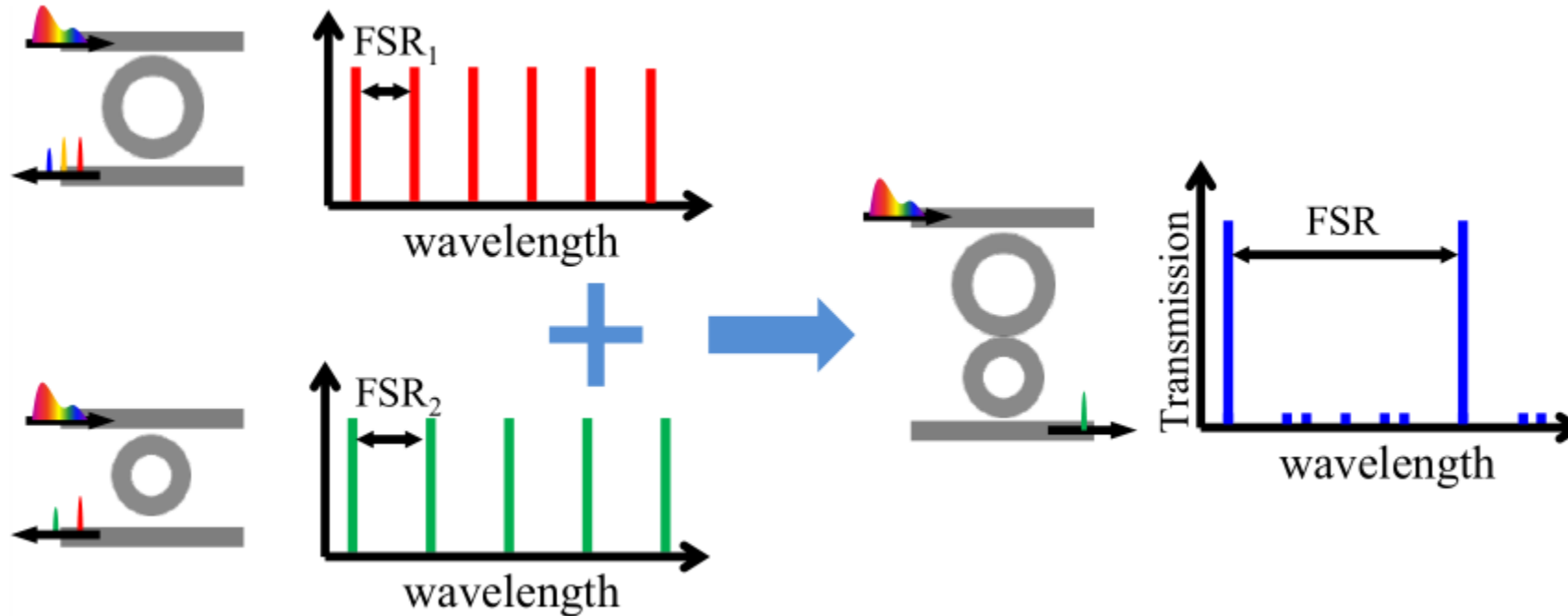
Optics Letters 2019, 706 (5).

Digital FTS



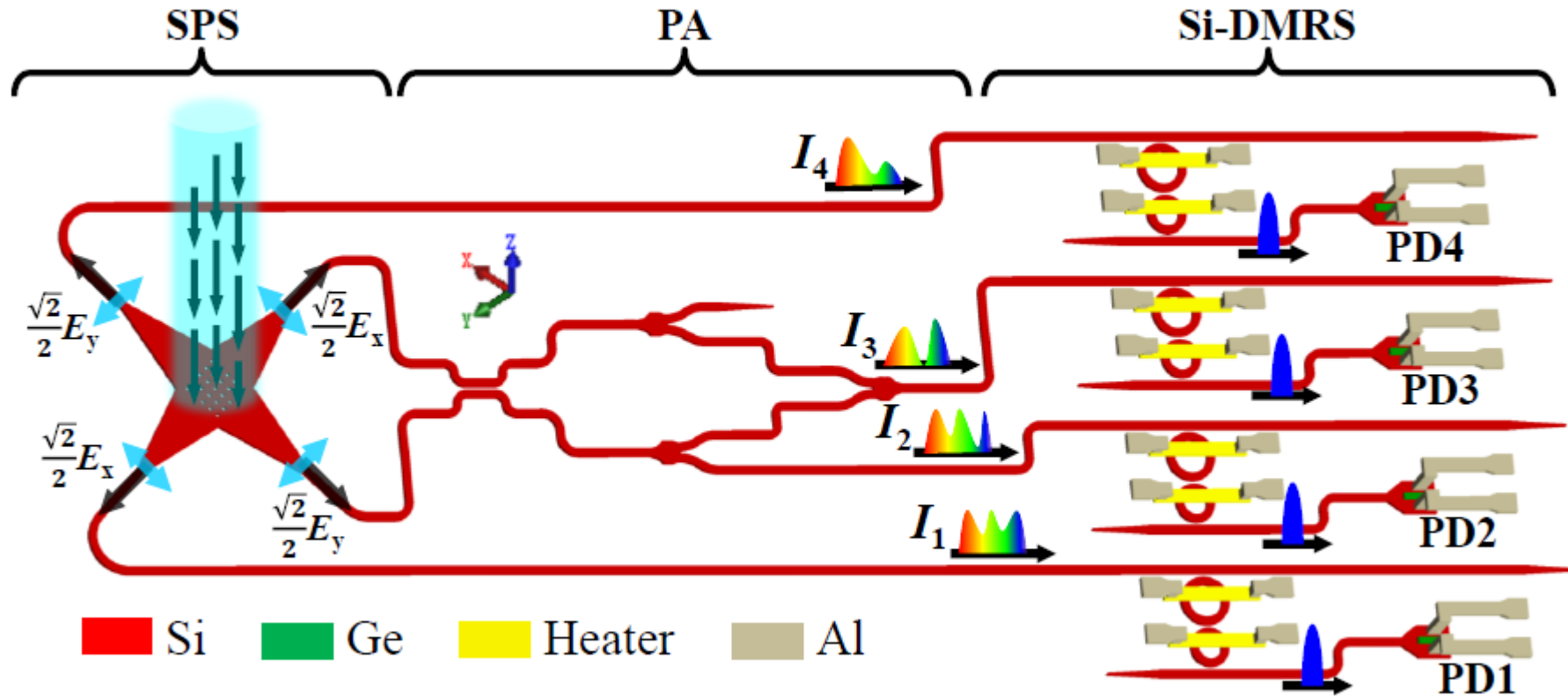
Complex control

Spectropolarimeter : design of spectrometer

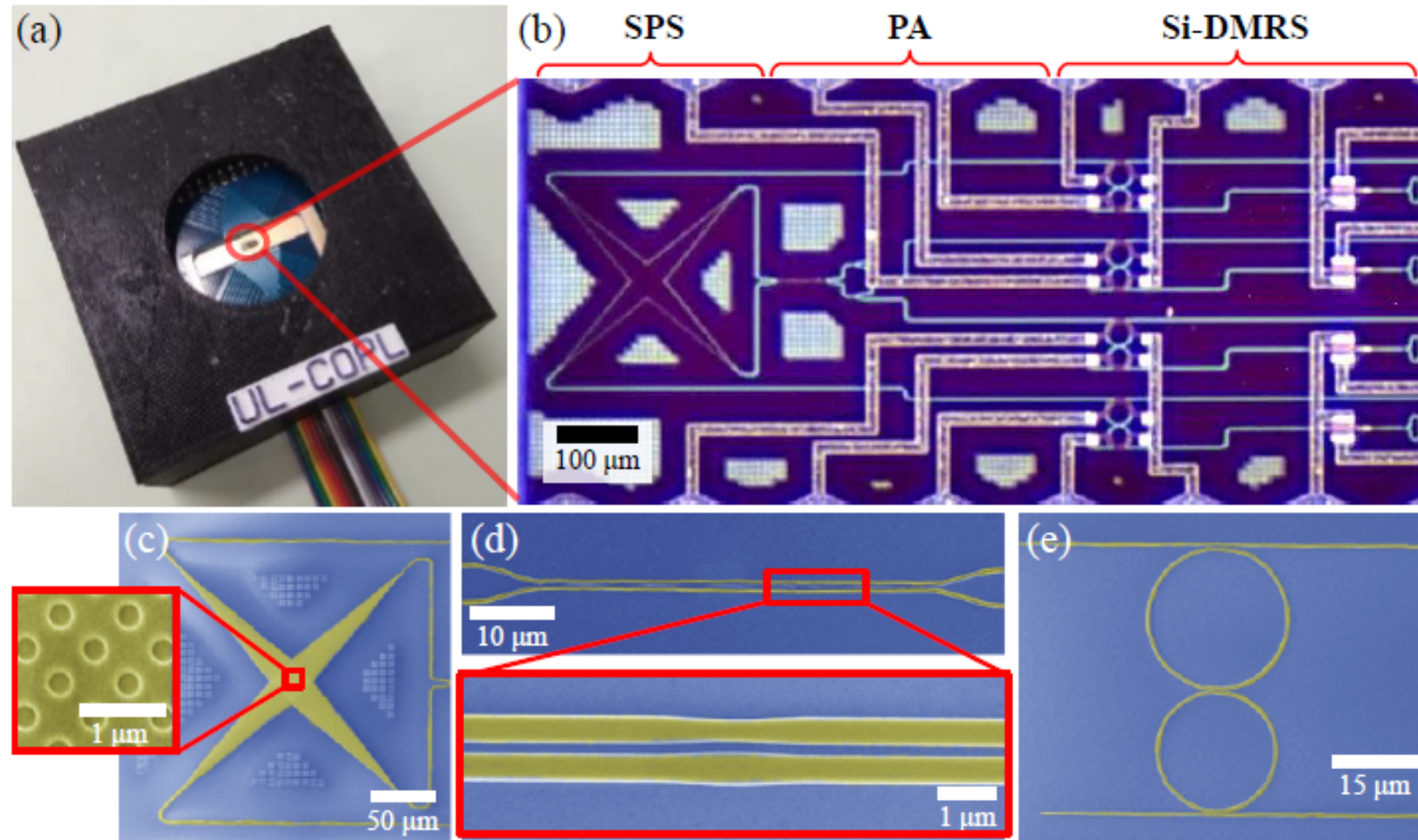


$$\text{FSR} = \frac{\text{FSR}_1 \cdot \text{FSR}_2}{|\text{FSR}_1 - \text{FSR}_2|} = \frac{\lambda^2}{\pi |D_1 n_{g2} - D_2 n_{g1}|} \approx \frac{\lambda^2}{\pi n_{g1} |D_1 - D_2|}$$

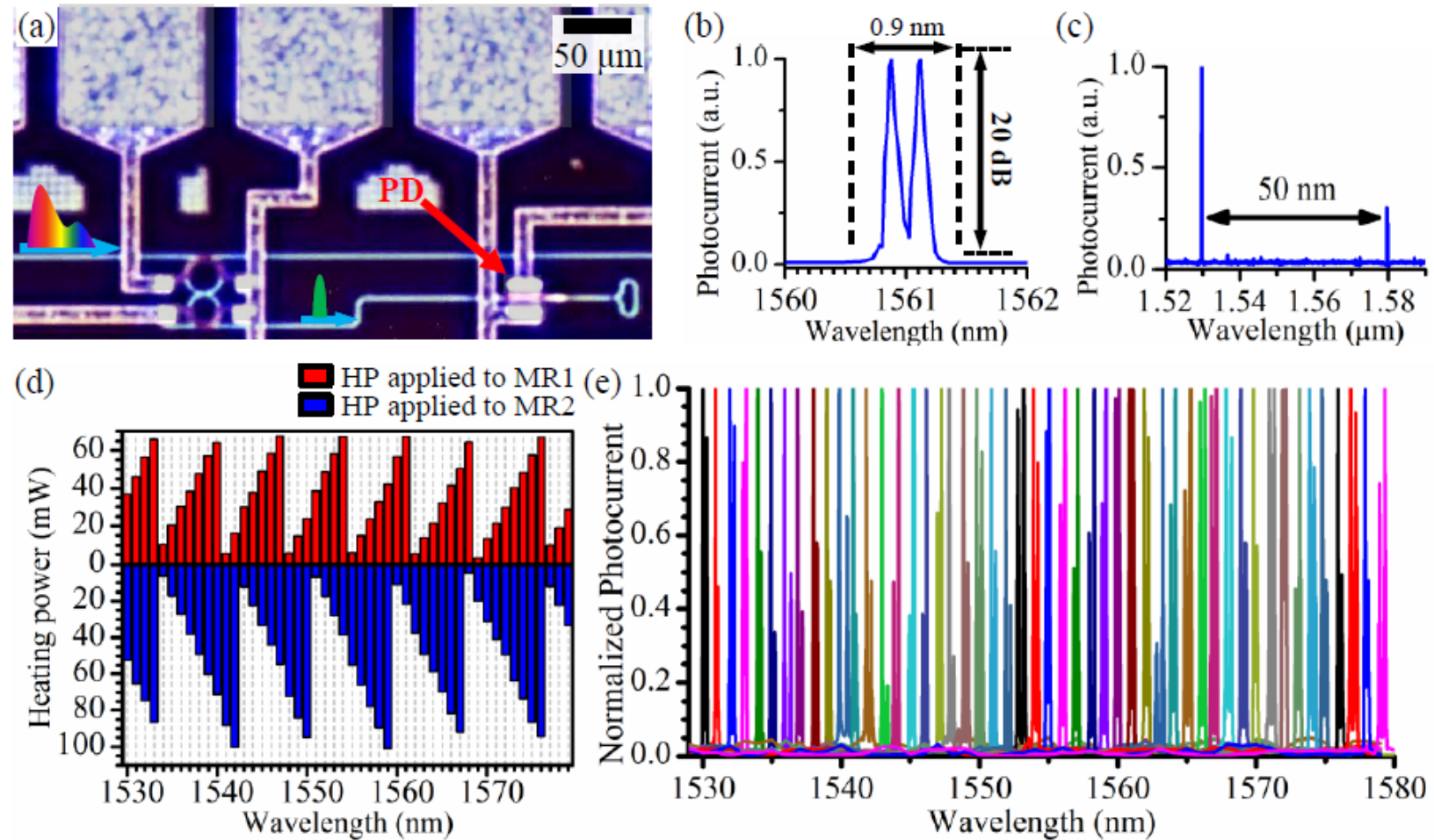
Spectropolarimeter : design of spectrometer



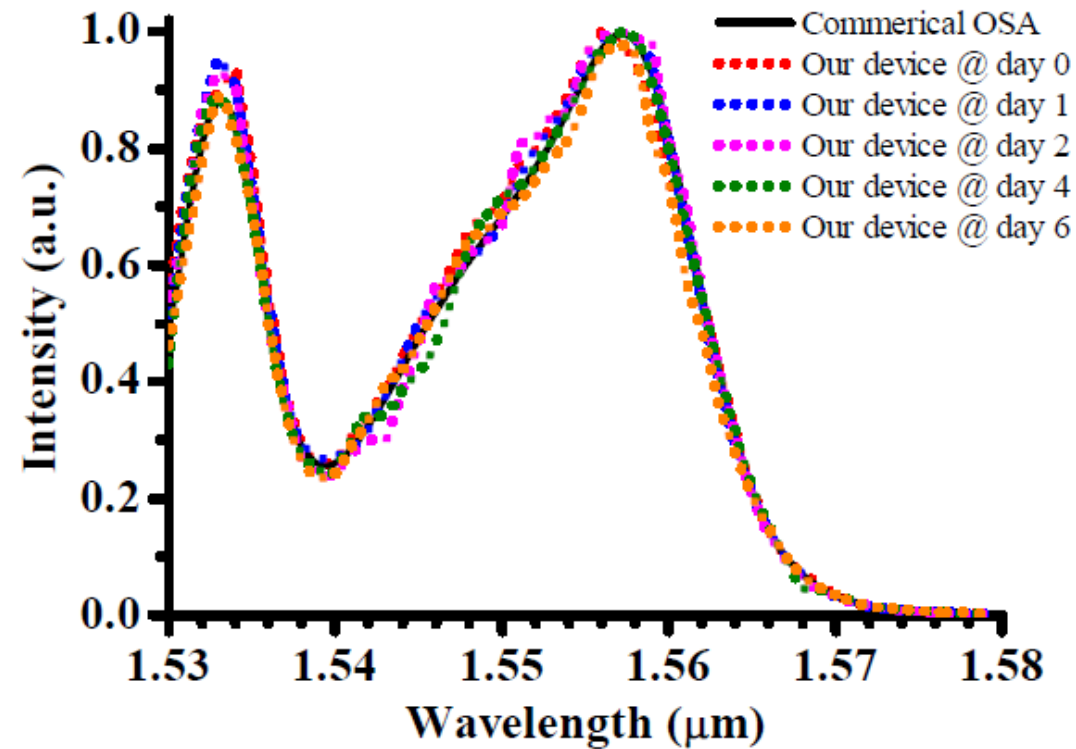
Spectropolarimeter : prototype



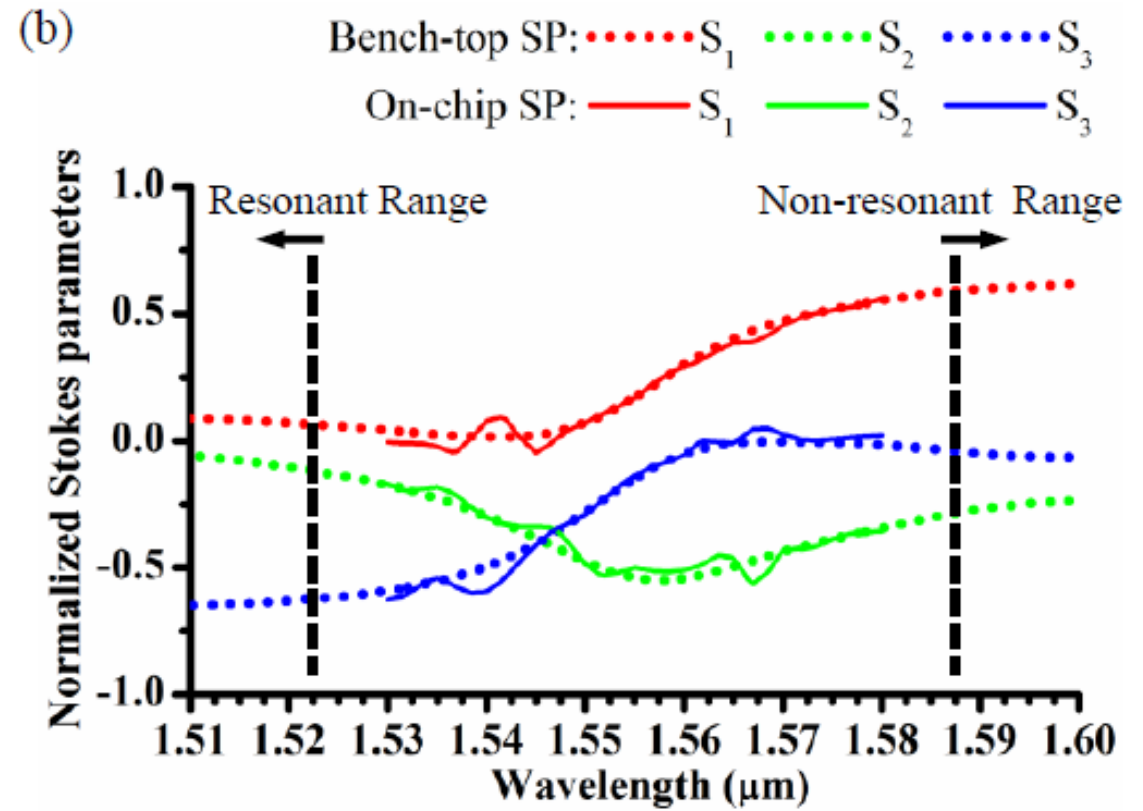
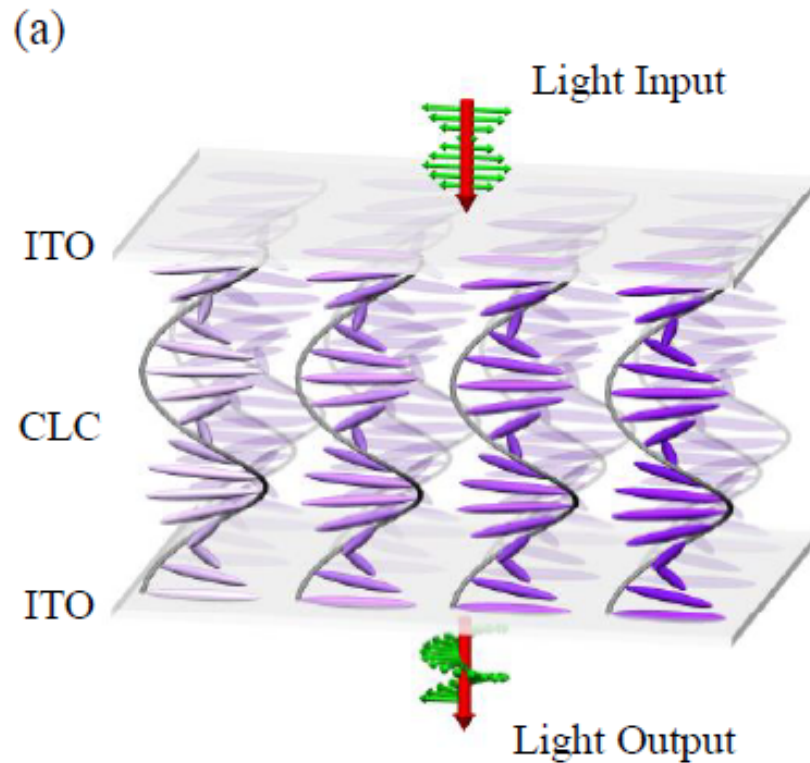
Calibration of the spectrometer



Performance of the spectrometer



Characterization of a chiral material



Summary

- Ultra-compact full-Stokes polarimeter using a CMOS-compatible fabrication process.
 - The optimal frame (in presence of both Gaussian and Poisson noises) is achieved, for the first time, in a silicon photonic circuit.
- Spectropolarimeter: on-chip probing information carried by both wavelength and polarization
- Promising for a broad application thanks to their compact footprint, low power consumption, low cost, and robustness



Thanks!

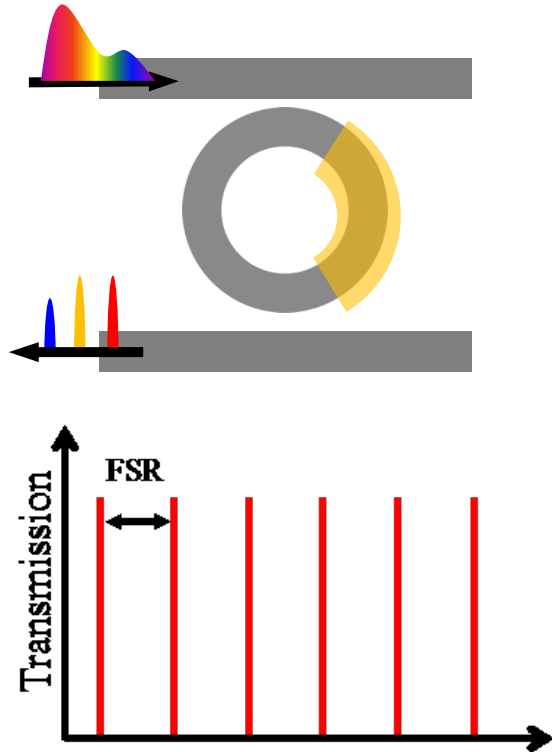
Our group's website:



Acknowledgment:



Spectropolarimeter : design of spectrometer



Advantage:

Small footprint, low power consumption

Problem:

(1) the inverse relationship between the size and free spectral range (FSR)

FSR=50 nm $\longrightarrow$ Diameter = 2 μ m

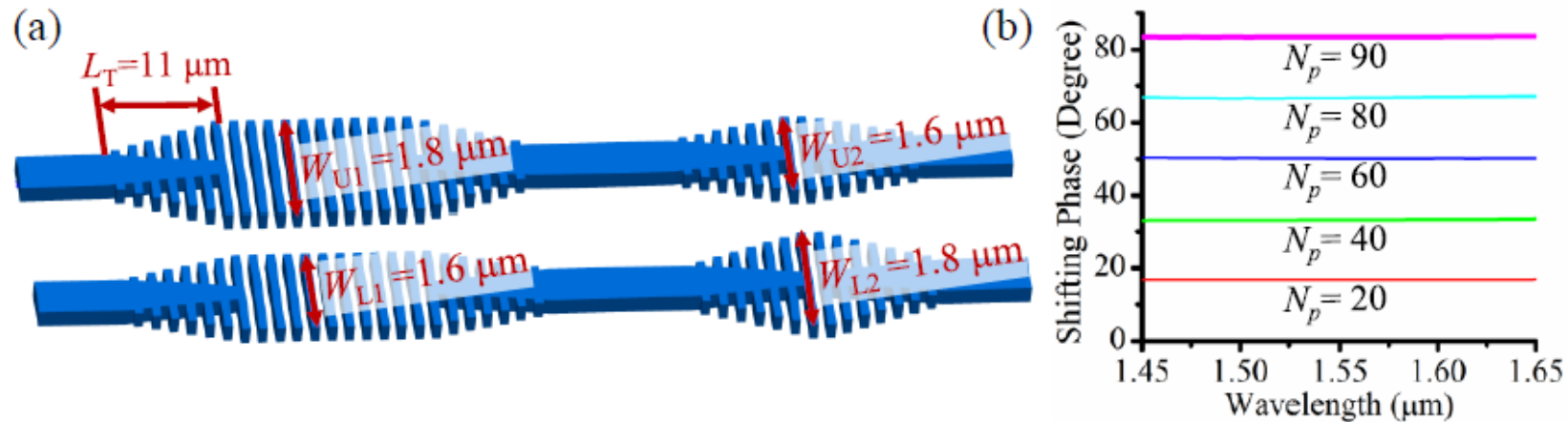
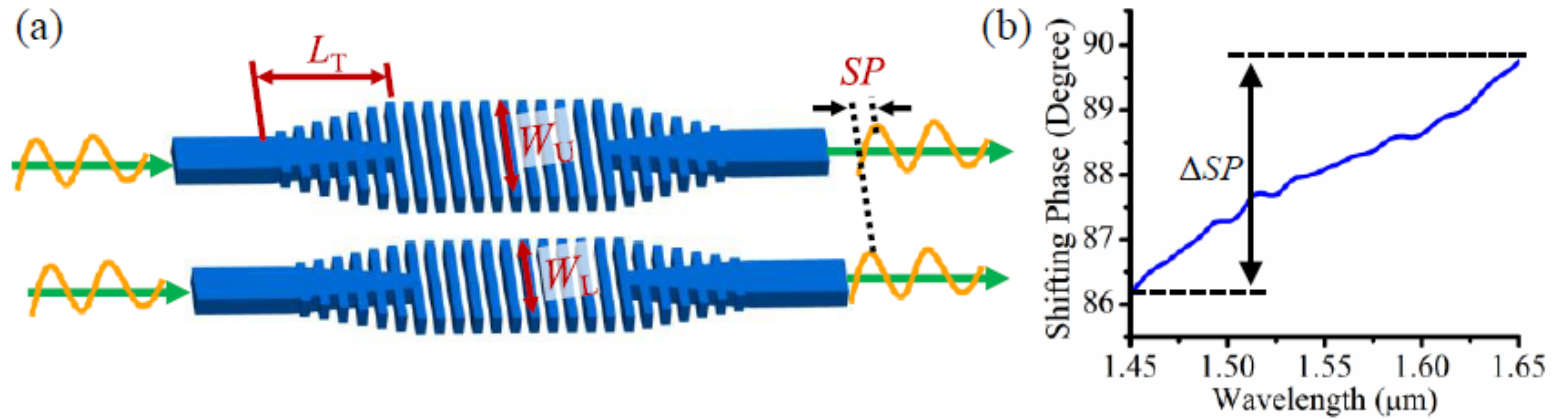
(2)

$$\Delta\lambda = \frac{\lambda}{n_{eff}} \times \frac{dn_{eff}}{dT} \Delta T$$

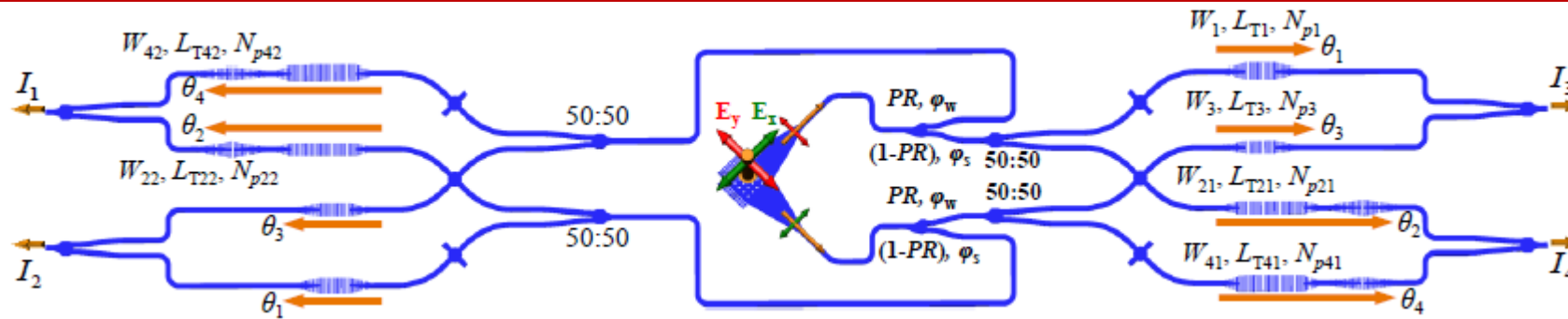
1 nm $\longrightarrow$ 10 $^{\circ}$ C

50 nm $\longrightarrow$ 500 $^{\circ}$ C

Broadband and optimal polarimeter

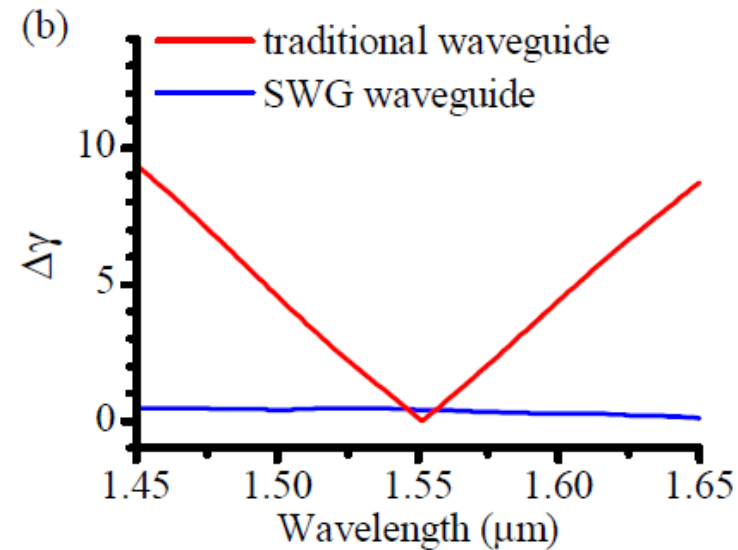
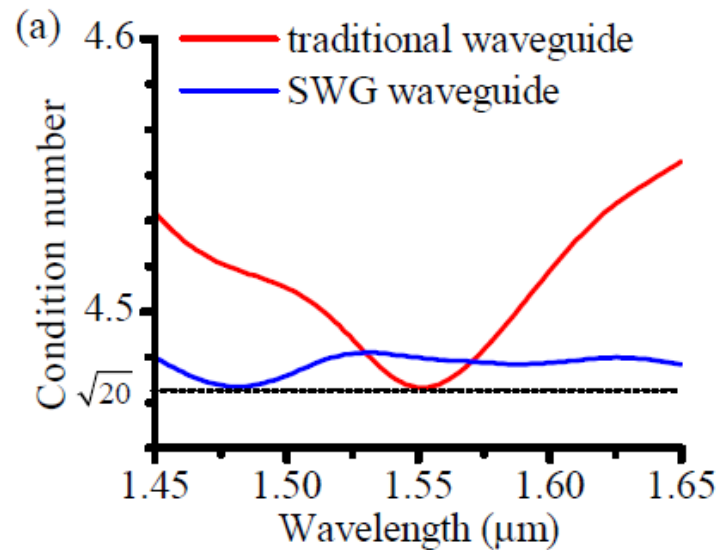


Broadband and optimal polarimeter



Gaussian noise

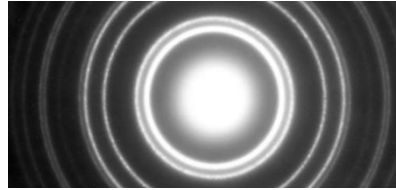
Poisson noise



Introduction



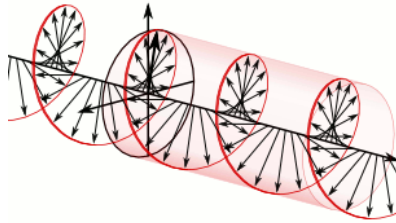
Intensity



Color (Frequency)



Polarization state



Had been studied for a long history

Stokes vector is used to describe the polarization since 1850s

